

<b>PATENT ASSIGNMENT COVER SHEET</b>
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EPAS ID: PAT5238432

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
STEFAN ALEXANDER ARNOLD	12/31/2017
THOMAS BRAUN	01/03/2018
HENNING STAHLBERG	01/04/2018
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<b>State/Country:</b>	SWITZERLAND
<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
<b>Application Number:</b>	15742532
<b>CORRESPONDENCE DATA</b>	
<b>Fax Number:</b>	
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<b>ATTORNEY DOCKET NUMBER:</b>	95083/306.9
<b>NAME OF SUBMITTER:</b>	MICHAEL D. HAMMER
<b>SIGNATURE:</b>	/Michael D. Hammer/
<b>DATE SIGNED:</b>	11/15/2018
<b>Total Attachments: 3</b>	
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source=95083_306_9_assign3#page1.tif	

ASSIGNMENT

For good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, the undersigned:

**Stefan Alexander ARNOLD, Wildensteinerstrasse 10, 4052 Basel, Switzerland,  
Thomas BRAUN, Baumgartenweg 26, 4142 Munchenstein, Switzerland, and  
Henning STAHLBERG, Rottmannsbodenstrasse 59, 4102 Binningen, Switzerland,**

(hereinafter: "Assignors");

hereby assign, transfer, convey, and deliver to:

**UNIVERSITAT BASEL, Vizerektorat Forschung Petersgraben 35, 4003 Basel, Switzerland** (a university incorporated under the laws of Switzerland)

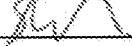
(hereinafter: the "Assignee"), its legal successors and assigns, the Assignors' entire right, title and interest in and to the invention entitled:

**LOSSLESS CRYO-GRID PREPARATION STAGE FOR HIGH-RESOLUTION ELECTRON MICROSCOPY** (hereinafter: the "Invention").

The Invention is described and claimed in International Patent Application No. **PCT/EP2015/065398** filed on July 6, 2015 (hereinafter: the "Patent Application").

The rights assigned herein include, without limitation, all rights in and to the Patent Application and all patent applications derived therefrom, including any United States National Stage, continuation, continuation-in-part, divisional, extension, reexamination, substitute and renewal thereof, and any patent application filed anywhere in the world claiming priority to the Patent Application under international conventions, and any and all Letters Patent which may be granted thereon; and all rights to collect and retain all royalties and other considerations arising from the Invention; and all rights to sue for past, present and future infringement and the right to collect and retain all damages collected or awarded as a consequence of such infringement.

The undersigned authorize and request the Director of the United States Patent and Trademark Office, and any official of any country whose duty it is to issue patents on applications as aforesaid, to issue Letters Patent to said Assignees; and agree to sign all lawful papers, make all rightful oaths, and do all lawful acts requisite for filing and prosecuting the Patent Application, and for obtaining and enforcing patent protection for the Invention.

X   
\_\_\_\_\_  
**Stefan Alexander ARNOLD**  
Date: 30.02.17

X \_\_\_\_\_  
**Thomas BRAUN**  
Date: \_\_\_\_\_

X \_\_\_\_\_  
**Henning STAHLBERG**  
Date: \_\_\_\_\_

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X

\_\_\_\_\_  
**Stefan Alexander ARNOLD**

Date: \_\_\_\_\_

x

\_\_\_\_\_  
**Thomas BRAUN**

Date: \_\_\_\_\_

x

  
\_\_\_\_\_  
**Henning STAHLBERG**

Date: Jan 4, 2018

ASSIGNMENT

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X  
\_\_\_\_\_  
**Stefan Alexander ARNOLD**  
Date: \_\_\_\_\_

x   
\_\_\_\_\_  
**Thomas BRAUN**  
Date: 3.1.2018

x  
\_\_\_\_\_  
**Henning STAHLBERG**  
Date: \_\_\_\_\_